

Application Serial No. 10/569,167
Response to Office Action

Customer No. 01933

Attorney Docket No. 06089/LH

This paper is being submitted
via EFS-Web on June 25, 2010

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Keiichi TANAKA

Serial No. : 10/569,167

Confirm. No.: 1699

Filed : October 24, 2006

For : VACUUM DEVICE, OPERATION METHOD
FOR VACUUM DEVICE, EXPOSURE
SYSTEM, AND OPERATION METHOD FOR
EXPOSURE SYSTEM

Art Unit : 2882

Examiner : STEVEN H. WHITESELL GORDON

In the event that this Paper is
late filed, and the necessary
petition for extension of time
is not filed concurrently
herewith, please consider this
as a Petition for the requisite
extension of time, and to the
extent not already paid,
authorization to charge the
extension fee to Account
No. 06-1378. In addition,
authorization is hereby given to
charge any fees for which
payment has not been submitted,
or to credit any overpayments,
to Account No. 06-1378.

A M E N D M E N T

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R :

This is responsive to the Office Action mailed
April 9, 2010, the term for response to which expires on
July 9, 2010.

Amendments to the Claims are set forth in the listing of
claims which begins on page 2. Claims 1, 2, 5, 6, 8, and 11-13
are amended, and claims 3, 4, 7, 9, 10, and 14 are canceled.

Remarks begin on page 6.